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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)			Application Number	10/781,828	
			Filing Date	February 20, 2004	
			First Named Inventor	Yong Cheol PARK	
			Art Unit	2627	
			Examiner Name	V. T. Pham	
Sheet	4	of	9	Attorney Docket Number	0465-1154P

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Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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Examiner Signature	/Van Pham/	Date Considered	11/20/2008
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